

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Hiroyuki Fujimura, et al

Serial No.: 10/540,640

Art Unit: 1794

Filed: March 29, 2006

Examiner: A. Turner

For: DIAMOND FILM-FORMING SILICON
AND ITS MANUFACTURING METHOD

VIA EFS-Web
Total Pages: 18

RESPONSE

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:


This Response is being filed in reply to the non-final
office action dated April 18, 2008.

Amendments to the Claims begin on page 2.

Remarks begin on page 7.

CERTIFICATE OF EFS TRANSMISSION

I hereby certify that this correspondence is being filed electronically with the United States Patent and
Trademark Office on July 15, 2008.


Debbie Smith